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• •				Application Number	10/659,136	
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;	STATEMENT BY APPLICANT			First Named Inventor	Stojakovic	
				Art Unit	IBB- 24/3	
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Sheet	11	of	1	Attorney Docket Number	2003 P 50794 US	

	U.S. PATENT DOCUMENTS						
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		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
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Ams	1	KIM, H.W., et al., "Effect Of Ti-Mask Addition And Temperature Elevation On O <sub>2</sub> /Cl <sub>2</sub> Plasma Etching Of Pt," Journal of the Korean Physical Society, Vol. 42, No. 5 (May 2003) pp. 667-670.	
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				Application Number	TBD /0/659 136		
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9	STATEMENT BY APPLICANT			First Named Inventor	Stojakovic, et al.		
				Art Unit	<del>188</del> 2813		
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Sheet	1	of	1	Attorney Docket Number	2003 P 50794 US		

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